IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Ramachandran, *et al.*	Docket No.:	INTECH 3.0-081 (02 P 15180 US)
Serial No.:	10/685,684	Art Unit:	1746
Filed:	October 15, 2003	Examiner:	El Arini, Zeinab
For:	Semiconductor Device Cleaning Employing Heterogeneous Nucleation for Controlled Cavitation		

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

The following amendments and remarks are presented in response to the Examiner's Office Action mailed September 5, 2006. Please amend the above-referenced application as follows.